



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/615,926 Confirmation No. : 9914

First Named Inventor : Hideaki YAMASAKI

Filed : July 10, 2003

TC/A.U. : 1763

Examiner : J. R. Lund

Docket No. : 010986.52578US

Customer No. : 23911

Title : Film-Formation Apparatus and Source Supplying

Apparatus Therefor, Gas Concentration Measuring Method

Mail Stop AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT

Sir:

The following amendments and remarks are respectfully submitted in response to the Office Action dated June 23, 2005.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.